

Docket No.: 52352-785



PATENT

Handwritten: #10/13
[Signature]
7/11/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

George Jonathan KLUTH, et al.

Serial No.: 10/071,207 ✓

Group Art Unit: 2822

Filed: February 11, 2002

Examiner: GUERRERO, Maria F.

For: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE WITH
SUPERSATURATED SOURCE/DRAIN EXTENSIONS AND METAL SILICIDE
CONTACTS

AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RECEIVED
JUN - 2 2003
TECHNOLOGY CENTER 2800

Sir:

These amendments and remarks are being filed in response to the Office Action
dated March 31, 2003.

This response is being filed in accordance with the Waiver of 37 C.F.R. § 1.121
pursuant to the Pre-OG Notices of January 31, 2003.